

Electronic Information Disclosure Statement



DRYING PROCESS FOR LOW-K DIELECTRIC FILMS

Application:

10/065861

Confirmation: 3384

Applicant(s): Carlo Waldfried

Docket

ATI-0016

Group Art

Unit: 1746

Examiner:

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(4341592 or 4885047 or 5498308 or 6203582 or 6235453 or 6238161 or 6281135 or 6328809 or

search string: 20010010950 or 20010048867 or 20010030101 or 20010051082 or 20020033136 or 20010037822 or 20020037655).pn.

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US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Citation No.	Patent Number	Date	Bar Code	Patentee	Class	Subclass
<input checked="" type="checkbox"/>	P01	4341592	1982-07-27	[Barcode]	Shortes, et al.		
<input checked="" type="checkbox"/>	P02	4885047	1989-12-05	[Barcode]	Ury, et al.		
<input checked="" type="checkbox"/>	P03	5498308	1996-03-12	[Barcode]	Kamarehi, et al.		
<input checked="" type="checkbox"/>	P04	6203582	2001-03-20	[Barcode]	Berner, et al.		
<input checked="" type="checkbox"/>	P05	6235453	2001-05-22	[Barcode]	You, et al.		
<input checked="" type="checkbox"/>	P06	6238161	2001-05-29	[Barcode]	Kirkpatrick, et al.		

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<i>AM</i>	P07	6281135	2001-08-28		Han, et al.
<i>AM</i>	P08	6328809	2001-12-11		Elsawy, et al.

Published Applications

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Citation No.	Patent Number	Date	Bar Code	Patentee	Class	Subclass
<i>AM</i>	U01	20010010950	2001-08-02		Savage, et al.		
	U02	20010048867	2001-12-06		Lebar, et al.		
	U03	20010030101	2001-10-18		Berner, et al.		
	U04	20010051082	2001-12-13		Kirkpatrick, et al.		
	U05	20020033136	2002-03-21		Savage, et al.		
	U06	20010037822	2001-11-08		Elsawy, et al.		
<i>AM</i>	U07	20020037655	2002-03-28		Hasunuma, et al.		

Signature

Examiner Name	Date
<i>A. Marshall</i>	<i>12/12/04</i>

